

Notice of References Cited

Application/Control No.

10/639,942

Applicant(s)/Patent Under
Reexamination
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Examiner

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Art Unit

2812

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley Wolf and Richard N, Tauber, Silicon Processing For The VLSI Era, 1986, Lattice Press, Vol. I, pages 303-308
	V	Stanley Wolf, Silicon Processing For The VLSI Era, 1990, Lattice Press, Vol. II. pages 45-47 and 144-146
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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